FORM 1449 INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use several sheets if necessary)					Atty. Doc P29771	ket No.	Application No. 10/576.023		
						Applicant Kimiaki TOSHIKIYO			
						1.A. Filing Date December 15, 2004		Group 2622	
			U.	S. PATENT DOC	UMENTS				
EXAMINER		DOCUMENT					FILING DATE		
INITIAL	-	NUMBER	DATE	NAME	CLASS	SUBCLASS	IF APPROPRIATE		
	A B	5561558 5742433	10/01/1996	Shiono et al.					
	С		04/21/1998	Dobashi et al.					
	D	2003/0179457 7250973	09/25/2003	Dobashi et al.					
	E	1230913	07/31/2007	Dobasni et ai.					
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			FOF	REIGN PATENT DO	CUMENTS				
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES	ENGLISH ABSTRACT YES	
	N	2003-243638	08/29/2003	JAPAN	****			Х	
	0	2004-096358	03/25/2004	JAPAN				Х	
	P	7-113907	05/02/1995	JAPAN				Х	
	Q	7-113906	05/02/1995	JAPAN				Х	
	R								
	S								
	Т								
	υ								
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)									
	1	Donald C. O'Shea et al., "Diffractive Optics Design, Fabrication, and Test", SPIE PRESS, pp.54-56, 12/29/2003.							
	2	Toshikiyo et al "A MOS Image Sensor with Microlenses Built by Sub-Wavelength Patterning", 2007 IEEE ISSCC session 28.8 K, 02/14/2007.							
	3	JAPAN Office action, mail date is 03/22/2011.							
	4	Response to an Office Action to the corresponding Chinese patent application No. 200480042730.2 (with a partial English translation of relevant portion).							
	5								
EXAMINER	EXAMINER: /Dwight Alex C Tejano/ DATE CONSIDERED 05/07/2011 *EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609: draw line through citation if not in								
		l if citation considered considered. Include				U9: draw line thr	ough citation if not i	n	